

## **Preliminary agreement with Siltronic AG on the supply of crystal growing systems**

**(Aslar, 24 July 2006) – Crystal Growing Systems (CGS) GmbH, Aslar, a wholly-owned subsidiary of PVA TePla AG, Aslar, concluded a letter of intent on the supply of crystal growing systems with Siltronic AG, Munich, a wholly-owned subsidiary of Wacker Chemie AG, in the amount of around EUR 60 million on 24 July 2006.**

The EKZ 3000/450 systems will be used to produce 300mm wafers for the semiconductor market in a joint venture between Siltronic AG and Samsung Electronics Co, Ltd., Singapore. With this system type, CGS GmbH is supporting the technological shift from 200mm to 300mm wafers within the semiconductor industry. The EKZ 3000 was developed in cooperation with Siltronic as part of a government-sponsored project and represents the state of the art in the area of silicon crystal growth.

The crystal growing systems will be delivered to the joint venture in the course of 2007 and 2008, and will form the first development phase in the new production of 300mm wafers. The final agreement between CGS GmbH and Siltronic AG will be concluded by 30 September 2006.

Dr. Andreas Mühe, Managing Director of CGS GmbH and head of the Crystal Growing division of PVA TePla AG, will leave the Company at the end of August 2006 and become the head of the "Crystal Centre" at Siltronic AG.

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